



#8/B(U/E)
12/7/00
Vivanna
RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2811

PATENT APPLICATION
Do. No. 5484-48

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup SHIM et al.

Serial No. 09/305,240

Examiner: O. Nadav

Filed: May 4, 1999

Group Art Unit: 2811

For: **OPEN DRAIN INPUT/OUTPUT STRUCTURE AND MANUFACTURING
METHOD THEREOF IN SEMICONDUCTOR DEVICE**

Date: November 30, 2000

Box AF
Assistant Commissioner for Patents
Washington, D.C. 20231

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AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Responsive to the final Office Action, dated August 31, 2000, please amend the application as follows.

IN THE SPECIFICATION

On page 2, line 25, replace "FIG.s" with --FIGs.--;

On page 4, line 9, replace "a n-type" with --an n-type--.

IN THE CLAIMS:

Please amend the claim as follows: